

QSM&N File No. 206138US0

By: JDM/REM/mab

Serial No. 09/834,950

In the matter of the Application of: Yoshihiko YANO

For: FLUORESCENT THIN FILM, ITS FABRICATION PROCESS, AND EL  
PANEL

Due Date: 04/17/03 & 04/27/03

The following has been received in the U.S. Patent Office on the date stamped hereon:

- Check for \$180.00
- Deposit Account Order Form
- PTO Cover Letter
- Response
- Information Disclosure Statement
- Form PTO-1449
- Cited References (2)
- Statement of Relevancy
- Japanese Official Action w/English Translation

